



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Micha Gutman et al.

Assignee: Tower Semiconductor, Ltd.

Title: "Method of Decreasing Charging Effects in Oxide-Nitride-Oxide (ONO) Arrays"

Serial No: 10/659,042

Art Unit: 2812

Filed: 9/9/2003

Examiner: Walter Lee Lindsay, Jr.

November 4, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO FIRST OFFICE ACTION

Sir:

Applicants submit the following remarks and amendments in response to the Office Action dated May 4, 2005. A petition for a 3-month extension, extending the period for response to November 4, 2005, accompanies the present response.